

Letter

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¹ CO₂ Reduction to Methanol on TiO₂-Passivated GaP Photocatalysts

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- 5 Supporting Information

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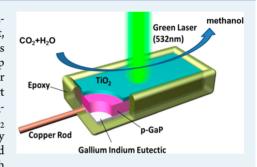
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ABSTRACT: In the past, the electrochemical instability of III–V semi-conductors has severely limited their applicability in photocatlaysis. As a result, a vast majority of the research on photocatalysis has been done on ${\rm TiO_2}$, which is chemically robust over a wide range of pH. However, ${\rm TiO_2}$ has a wide band gap (3.2 eV) and can only absorb ~4% of the solar spectrum, and thus, it will never provide efficient solar energy conversion/storage on its own. Here, we report photocatalytic ${\rm CO_2}$ reduction with water to produce methanol using ${\rm TiO_2}$ -passivated GaP photocathodes under 532 nm wavelength illumination. The ${\rm TiO_2}$ layer prevents corrosion of the GaP, as evidenced by atomic force microscopy and photoelectrochemical measurements. Here, the GaP surface is passivated using a thin film of ${\rm TiO_2}$ deposited by atomic layer deposition (ALD), which



provides a viable, stable photocatalyst without sacrificing photocatalytic efficiency. In addition to providing a stable photocatalytic surface, the ${\rm TiO_2}$ passivation provides substantial enhancement in the photoconversion efficiency through passivation of surface states, which cause nonradiative carrier recombination. In addition to passivation effects, the ${\rm TiO_2}$ deposited by ALD is n-type due to oxygen vacancies and forms a pn-junction with the underlying p-type GaP photocathode. This creates a built-in field that assists in the separation of photogenerated electron—hole pairs, further reducing recombination. This reduction in the surface recombination velocity (SRV) corresponds to a shift in the overpotential of almost 0.5 V. No enhancement is observed for ${\rm TiO_2}$ thicknesses above 10 nm, due to the insulating nature of the ${\rm TiO_2}$, which eventually outweighs the benefits of passivation.

KEYWORDS: photoelectrochemical, GaP, CO₂ reduction, TiO₂ passivated, methanol

he photoelectrochemical reduction of CO_2 is an exciting reaction system with the ability to convert an abundant 27 greenhouse gas to combustible hydrocarbon fuels using 28 sunlight. The direct conversion of solar-to-chemical energy 29 has several advantages over solar-to-electric energy conversion, 30 most notably, the ability to store large amounts of energy (~GW) in chemical bonds that can later be released in a carbon 32 neutral cycle. Many attempts have been made to reduce CO₂ 33 by 2e to various species such as CO and formic acid, as 34 reported in previous literature.² Few researchers have achieved 35 further reduction to CH₃OH or CH₄. Methanol is an attractive 36 product with a relatively high energy density, which can be 37 easily integrated into the existing liquid fuel technologies. 1g,4 38 However, the photocatalytic reduction of CO₂ with H₂O to 39 methanol requires six electrons and many intermediate species, 40 some of which have extremely high energy barriers. The most 41 likely first step in this multielectron reaction is the one electron 42 reduction to the CO₂⁻ intermediate, which lies 1.7 eV above 43 the conduction band of TiO2 and 1.2 eV above GaP. The 44 mechanism for electrochemical CO_2 reduction was first 45 proposed by Bockris et al.⁷ The high overpotential required 46 for this reaction was attributed to the formation of the CO₂ 47 intermediate, which consequently converts to CO via the 48 general process $CO_2 + e^- \rightarrow CO_2^-$, $CO_2^- + 2H^+ + e^- \rightarrow CO + 49 \text{ H}_2\text{O}.^{1c,i,3a,8}$ In 1978, Hallman's group first reported CO_2 50 reduction on p-GaP under 365 nm illumination with an 51 applied overpotential of -1.4 V (vs SCE).^{2a} Fujishima and

Honda demonstrated photoelectrocatalytic reduction of CO_2 to 52 formaldehyde and methanol by irradiating TiO_2 and GaP with 53 the UV light at an overpotential of -1.5 V (vs SCE). Seq. Canfield later reported CO_2 reduction to methanol on p-InP 55 with an overpotential of -1.3 V (vs SCE). More recently, 56 Bocarsly's group demonstrated pyridinium-catalyzed CO_2 57 reduction on GaP photocathodes with overpotentials between 58 -0.7 V and -0.2 V (vs SCE) under UV light. Despite these 59 interesting prior results, the stability of these materials against 60 photocorrosion has not been addressed.

In the work presented here, we investigate the photocatalytic 62 performance and stability of 62 performance and stability of 62 performance and stability of 63 photoelectrochemistry, and 64 optical microscopy. The photocatalytic efficiency is studied 65 systematically as a function of 67 layer thickness using a 67 NMR spectroscopy and gas chromatography, systematically as a 68 function of applied overpotential.

Zn doped p-type (100) oriented GaP with a dopant 70 concentration of $2 \times 10^{18}~\text{cm}^{-3}$ was used as the photocatalyst 71 for CO_2 reduction with an active area of 0.5 cm \times 1 cm. Atomic 72 layer deposition (ALD) of anatase TiO_2 was performed at 250 73 °C on the p-GaP wafers with TiCl_4 as the titanium source and 74

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75 water vapor as the oxygen source. The antase crystal phase was 76 verified by Raman spectroscopy. Using ellipsometry, we 77 established that 100 cycles of ALD produces a 4 nm thick 78 TiO₂ film and 1000 cycles produces a 40 nm film. A Ga—In 79 eutectic film was painted on the back of the p-GaP to form an 80 Ohmic contact. The Ga—In contact was then connected to the 81 external circuitry with a copper wire and coated with epoxy 82 cement to insulate it from the electrolytic solution, as illustrated 83 in Figure 1b. Although this planar geometry is not ideal for high

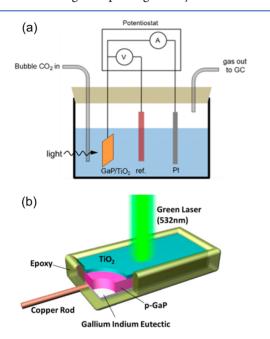


Figure 1. Schematic diagram of (a) photoelectrochemical measurement setup and (b) sample geometry of the ${\rm TiO_2}$ -passivated p-GaP photocathode.

84 efficiency photoconversion, it enables us to study surface stability. A three-terminal potentiostat was used with the prepared semiconductor samples as the working electrode, a Ag/AgCl electrode as the reference electrode, and a Pt electrode functioning as a counter electrode, as shown in Figure 1a. The photocatalytic reaction rates of two sets of samples were measured in a 2 mL solution of 0.5 M NaCl, with and without 10 mM pyridine, while continuously bubbling CO_2 through the solution. NaCl (0.5 M) was chosen as the electrolyte solution because of its high conductance and its ability to stabilize the intermediate states involved in the CO_2 reduction. In this setup, we analyze the products evolving at the working electrode, instead of at the counter electrode. It is likely that oxygen is also produced in the reaction.

While photocatalysis on GaP (and other III—V compound 99 semiconductors) has been demonstrated previously, 2h,3a,11 this 100 material corrodes rapidly under photoelectrochemical con101 ditions and is significantly degraded after just 30 min of 102 illumination. In order to make GaP photochemically stable, we 103 passivated the surface using a thin film of TiO_2 deposited by 104 ALD, as illustrated schematically in Figure 1b. Figure 2a,b show 105 optical microscope and atomic force microscope images of the 106 bare GaP surface after 8 h of illumination. Figure 2c shows a 107 plot of the surface topography obtained along the dashed white 108 line in Figure 2b, showing an RMS roughness of ± 54 nm, 109 which indicates that substantial photocorrosion has taken place 110 and that this will not serve as a viable photocatalyst. In contrast,

the photocurrent density of TiO_2 -passivated GaP is stable for 8 111 h. The optical microscope image (Figure 2d) and atomic force 112 microscope image (Figure 2e) exhibit no evidence of surface 113 corrosion or damage after 8 h, with an RMS roughness of ± 1 114 nm (Figure 2f), indicating that this is a long-term, stable 115 photocatalyst. Here, the TiO_2 significantly improves the 116 photostablity of the GaP surface, however, more extensive 117 time-dependent studies are needed in order to establish the 118 extent of this long-term stability.

In addition to providing a stable photocatalytic surface, the 120 TiO₂ passivation layer results in an increase in the photo-121 conversion efficiency. Figure 3a shows the photocurrent- 122 f3 voltage curves for GaP passivated with various thicknesses of 123 TiO₂ measured in a 0.5 M NaCl, 10 mM pyridine solution 124 under 532 nm illumination. During these measurements, CO₂ 125 is continuously bubbled through the solution. Bare GaP (green 126 curve) has an onset of photocurrent at a potential of 127 approximately -0.15 V (vs NHE). For TiO₂-passivated GaP, 128 we see a clear shift in the overpotential required to drive this 129 reaction with increasing thickness of the TiO2, as plotted in 130 Figure 3b. Table 1 lists the shift of onset overpotential of 131 t1 samples with different thicknesses of TiO2. For example, the 132 onset potential for 10 nm TiO₂ (red curve) is shifted by 0.5 V 133 with respect to bare GaP. This shift is attributed to the 134 passivation of surface states that cause nonradiative recombi- 135 nation and the formation of a pn-junction, which is created 136 because the ALD-deposited TiO2 tends to be n-type doped due 137 to oxygen vacancies. 12 Figure 3c shows the built-in potential for 138 the junction calculated using $V_{\rm bi} = (((W_{\rm D}^2 q)/(2 \ \epsilon_0 \ \epsilon_a \ \epsilon_d)) \ (N_a \ 139 \ N_{\rm d}(N_a \ \epsilon_a + N_{\rm d} \ \epsilon_d)/(N_a + N_{\rm d})^2))$, assuming a doping 140 concentration of $N_a = 5 \times 10^{18} {\rm cm}^3$. Here, $W_{\rm D}$ is the 141 depletion width of the GaP-TiO2 junction, which is a function 142 of the TiO₂ layer thickness. This simple calculation predicts 143 values similar to the experimentally observed shift in the 144 overpotential plotted in Figure 3b. Beyond 10 nm, however, the 145 photocurrent decreases rapidly with increasing TiO₂ thickness 146 due to band bending at the n-type TiO2/electrolyte interface, 147 which blocks electrons. No enhancement is observed for TiO₂ 148 thicknesses above 10 nm, due to the insulating nature of the 149 TiO₂, which eventually outweighs the benefits of passivation. 150 Although TiO₂ does not absorb light at 532 nm, the pn- 151 junction formed with the GaP enables separation of the 152 photogenerated charge in the actively absorbing GaP. Figure 3d 153 shows the NMR spectra taken after 8 h of illumination with an 154 overpotential of -0.50 V vs NHE for GaP with and without 155 TiO₂ passivation. These data show a clear peak corresponding 156 to methanol, as reported previously by Barton et al.^{3a} Gas 157 chromatography FID data have also been used to verify the 158 production of methanol, as shown in Supporting Information 159 Figure S1. On the basis of these GC FID data for the 5 nm 160 thick TiO₂ sample, we calculated that 4.9 (± 0.02) μ mol of 161 CH₃OH are produced during an 8 h reaction consuming 5.2 162 Coulombs of charge. Dividing by this ratio by the 163 stoichiometric factor of 6, yields a Faradaic efficiency of 55%. 164 Also, according to the GC TCD data of the same experiment, 165 H₂ is produced with a Faradaic efficiency of 30%. The 166 photoconversion efficiency, however, can be significantly less 167 than this due to nonradiative recombination, which is unknown, 168 particularly for this planar sample geometry. As a control 169 experiment, the same reaction was run under the same 170 electrochemical conditions of -0.50 V vs NHE without laser 171 illumination, which resulted in no measurable current and no 172 detectable methanol in the NMR spectra. In order to rule out 173

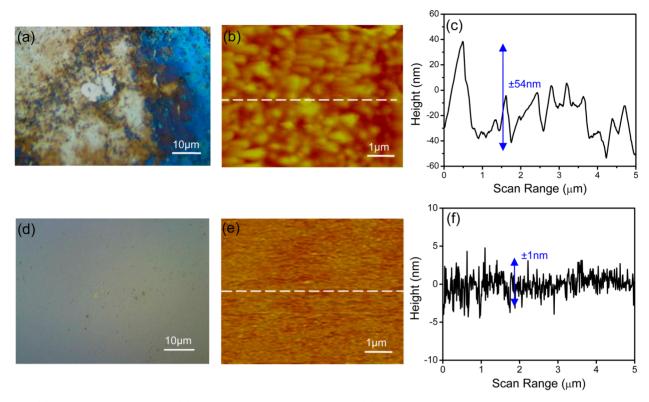


Figure 2. (a) Optical microscope image, (b) atomic force microscope image, and (c) surface topography of bare GaP surface after an 8 h reaction at -0.5 V overpotential. (d) Optical microscope image, (e) atomic force microscope image, and (f) surface topography of 5 nm TiO₂ on GaP surface after an 8 h reaction.

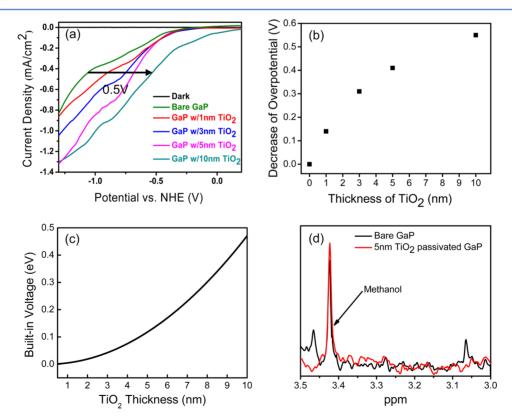


Figure 3. (a) Photocatalytic current—potential curves of GaP photocatalysts with different TiO_2 thicknesses in a 0.5 M NaCl, 10 mM pyridine solution under 532 nm wavelength laser illumination. (b) Decrease of overpotential plotted as a function of TiO_2 thickness on GaP. (c) Calculated built-in voltage plotted as a function of TiO_2 thickness. (d) NMR spectra showing methanol production using bare GaP and 5 nm TiO_2 -passiavated GaP photocatalysts at an overpotential of -0.50 V.

Table 1. Shift of Onset Overpotential for Samples with Different Thicknesses of TiO₂

	shift of onset overpotential compared to bare GaP
catalysts	(V)
bare GaP	0
1 nm TiO ₂ @GaP	0.13
3 nm TiO ₂ @GaP	0.31
5 nm TiO ₂ @GaP	0.40
10 nm TiO ₂ @GaP	0.52

174 other sources of carbon in this reaction, we used isotopically 175 labeled ¹³CO₂ as the carbon source in this reaction and 176 observed ¹³CH₃OH in the ¹³C NMR spectrum shown in 177 Supporting Information Figure S5. 14 In addition, we repeated 178 the experiment, purging with Ar instead of CO2, and found no 179 production of hydrocarbons. Therefore, we are confident that 180 CO₂ is the only carbon source in this reaction. Previously, it 181 was reported that a pyridine catalyst is required to drive this 182 reaction on GaP. The pyridinium radical serves as a one-183 electron charge-transfer mediator, which is capable of efficiently 184 transferring all six electrons to reduce CO₂ to methanol, 185 thereby circumventing the high energy barrier of the one-186 electron reduction of CO₂ mentioned above. 11 However, we 187 observe the same methanol peak in our NMR spectra without 188 pyridine in solution (see Supporting Information Figure S2), 189 indicating that this catalyst is not, in fact, required to drive this 190 reaction at low overpotentials. Although CH₃OH products are 191 observed without pyridine, the yield is one-third that of the 192 system with pyridine, indicating that the pyridine, in fact, helps 193 lower the energy barriers of the reaction by forming an inner-194 sphere-type electron-transfer system. Atomic force micros-195 copy shows that the GaP/TiO2 is photochemically stable 196 without pyridine, as shown in Supporting Information Figure 197 S3.

In order to understand the mechanism of this reaction, we 199 must consider the energetics of the electrons in this 200 photocatalytic structure. The conduction bands of GaP and 201 TiO_2 lie slightly above NHE at -0.7 V and -0.2 V versus NHE, 202 respectively, as plotted in Figure 4. This leaves an energy 203 barrier of at least 1.2 V for the electrons to overcome in the 204 reduction of CO_2 . The -0.5 V externally applied overpotential

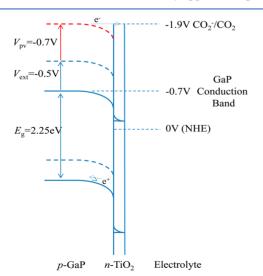


Figure 4. Energy band alignment of GaP and TiO₂ together with the relevant redox potentials of CO₂.

 $(V_{\rm ext})$ accounts for part of this required energy, and the 205 photovoltage produced at the internal pn-junction and/or the 206 liquid-semiconductor junction $(V_{\rm PV})$ can easily account for the 207 remaining -0.7 V, as depicted in Figure 4. From the flat-band 208 voltage, we can obtain the open circuit voltage, as follows: 209 $(V_{\rm oc})_{\rm max} = |V_{\rm fb} - V_{\rm redox}|$, where $V_{\rm fb}$ is flat-band potential and 210 $V_{\rm redox}$ is the potential of the redox couple. From Mott— 211 Schottky measurements, we obtained a flat-band potential of 212 0.4 V versus NHE, which is consistent with previous values 213 from literature. And it is large enough to cover the remaining $V_{\rm redox} = 0.76$ V, which 215 is large enough to cover the remaining $V_{\rm redox} = 0.76$ V, which 215 relatively large band gap of 2.25 eV.

These estimations assume that the electrons traverse the 219 TiO₂ layer ballistically and do not equilibrate to the TiO₂ 220 conduction band edge. In the diffusive case, an additional 0.5 V 221 would be required. We believe this is one of the reasons why 222 the TiO₂ layer must be made very thin. Several aspects of these 223 results and their underlying mechanism are quite surprising. 224 First, we had initially thought that the TiO2 layer, which is 225 insulating and has a low conduction band energy, would lower 226 the overall photocatalytic efficiency (i.e., photocurrent), but 227 would, at least, provide a stable, viable catalyst. Much to our 228 surprise, the TiO2 layer actually improved the overall 229 photoconversion efficiency. The reasons for this are 3-fold: 230 (1) The TiO₂ reduces nonradiative recombination of the 231 photoexcited electron-hole pairs. (2) The electrons traverse 232 the TiO₂ ballistically and, therefore, do not relax to the 233 conduction band edge. (3) The formation of a pn-junction 234 provides an additional photovoltage required to drive the 235 reaction.

It is important to note, however, that the CO₂⁻ reduction 237 potential of -1.9 V versus NHE is calculated from simple 238 thermodynamic considerations for isolated CO₂ species, and 239 does not include the effects of the solution or catalytic surface. 240 As a result, the energetics of the actual CO₂ intermediates can 241 be quite different due to the presence of the aqueous solution 242 and/or the catalytic surface. In a mechanism proposed by Anpo 243 et al., the CO₂ intermediate is strongly bound to a proposed 244 ${
m Ti}^{3+}$ active site (oxygen vacancy) on the ${
m TiO_2}$ surface, thus 245 lowering its energy. Another strategy for lowering the 246 reaction barrier is stabilizing the ${\rm CO_2}^-$ intermediate, which 247 was recently demonstrated using an ionic liquid electrolyte 248 cocatalyst where the cation forms a complex with the anionic 249 intermediate. ¹⁹ Two-electron processes have also been 250 proposed by Tananka et al., which would circumvent this first 251 intermediate step altogether.²⁰ Although several mechanisms 252 have been proposed in the literature, further spectroscopic 253 studies are needed in order to verify the catalytic reaction 254 pathway.

In conclusion, we report photocatalytic CO₂ reduction on 256 TiO₂-passivated GaP. The TiO₂ passivation layer successfully 257 stabilizes the GaP surface in solution, preventing it from 258 photocorrosion. In addition, the TiO₂ passivation layer 259 provides enhancement in the photoconversion efficiency 260 through the passivation of surface states and the formation of 261 a charge separating pn-region, which reduces carrier recombi- 262 nation and lowers the overpotential required to initiate this 263 reaction by approximately 0.5 V. This general approach of 264 passivating narrower band gap semiconductors with TiO₂ will 265 enable more efficient photocatalysts to be developed and a 266 broad range of materials to be considered for photocatalysis 267

268 that make more efficient use of the solar spectrum. We also 269 observe CH₃OH evolution with and without pyridine catalyst, 270 indicating that this catalysts is not, in fact, required to drive this 271 reaction at low overpotentials.

ASSOCIATED CONTENT

273 S Supporting Information

274 Gas chromatography data; ¹H NMR spectra of methanol; ²⁷⁵ images using optical microscopy, atomic force microscopy, and ²⁷⁶ surface topography, CH₃OH production plotted as a function ²⁷⁷ of time; and 13C NMR spectrum of methanol. This material is ²⁷⁸ available free of charge via the Internet at http://pubs.acs.org.

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282 Notes

283 The authors declare no competing financial interest.

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